

Notice of References Cited	Application/Control No. 09/824,301	Applicant(s)/Patent Under Reexamination BODE ET AL.	
	Examiner Sean P. Shechtman	Art Unit 2125	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,886,896 ✓	03-1999	Lantz et al.	364/468.23
	B	US-5,432,702 ✓	07-1995	Barnett	364/468
	C	US-6,442,445 ✓	08-2002	Bunkofske et al.	700/108
	D	US-6,041,270 ✓	03-2000	Steffan et al.	700/121
	E	US-6,303,395 ✓	10-2001	Nulman	438/14
	F	US-5,861,320 ✓	01-1999	Shiraishi	438/16
	G	US-6,197,604 ✓	03-2001	Miller et al.	438/14
	H	US-6,521,466 ✓	02-2003	Castrucci	438/5
	I	US-5,920,796 ✓	07-1999	Wang et al.	438/700
	J	US-2002/0055801 A1 ✓	05-2002	Reiss et al.	700/111
	K	US-2002/0116083 A1 ✓	08-2002	Schulze	700/108
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Michael Quirk, "Semiconductor Manufacturing Technology" December 15 th 2000, Prentice Hall, 1 st edition.
	V	Fukuda, "Advanced Process Control Systems Description of an easy-to-use control system incorporating pluggable modules" 1999, IEEE.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.